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Test Planning and Test Access Mechanism Design for Stacked Chips using ILP

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Abstract—In this paper we propose a scheme for test planning and test access mechanism (TAM) design for stacked integrated circuits (SICs) that are designed in a core-based manner. Our scheme minimizes the test cost, which is given as the weighted sum of the test time and the TAM width. The test cost is evaluated for a test flow that consists of a wafer sort test of each individual chip and a package test of the complete stack of chips. We use an Integer Linear Programming (ILP) model to find the optimal test cost. The ILP model is implemented on several designs constructed from ITC'02 benchmarks. The experimental results show significant reduction in test cost compared to when using schemes, which are optimized for non-stacked chips.

I. INTRODUCTION

The semiconductor technology development makes it possible to manufacture very complex integrated circuits (ICs). A single chip (die) can contain billions of transistors. To enable ICs with more transistors, it is possible with ICs where multiple chips are packaged in one single package. Examples of such ICs are multi-chip modules (MCMs), where the chips are placed laterally, and system in packages (SiPs), where the chips are stacked vertically and connected by bonding wires or solder bumps. The most recent advancement is ICs where multiple chips are stacked vertically and connected by interconnects known as Through-Silicon Vias (TSVs). These stacked ICs (SICs) have benefits such as increased performance, decreased power consumption and reduced form factor [1].

While manufacturing of ICs with a single chip per package, so called non-stacked ICs, is complex, manufacturing of SICs is more complex due to the need of additional manufacturing process steps related to the making and insertion of TSVs, thinning of chips, and alignment and bonding of the chips. A majority of IC manufacturers (approximately 85%) expect test cost to be the bottleneck in the production of SICs in the forthcoming years [2]. Test cost can be reduced by addressing problems related to fault modelling, wafer probing, design-for-test (DfT) architecture, and optimization of the test plan and test architecture [3].

In this paper we focus on test planning (test scheduling) and test access mechanism (TAM) design to reduce the test cost. We assume SICs developed using a core-based design methodology where each core is equipped with a core test wrapper.

The test cost is highly dependent on the test time and the DfT hardware. The DfT hardware for core-based ICs consists of (1) the TAM for the on-chip test data transportation between the automatic test equipment (ATE) and the embedded cores of the IC, and (2) the logic for core wrapper at each core. As each core is equipped with a wrapper, the cost for implementing the core wrappers becomes fixed. Thus, the cost of the DfT hardware highly depends on the TAM width. The test time and the TAM width are related. A narrow TAM leads to low DfT hardware but long test times, while a wide TAM increases the DfT hardware but enables lower test times. For that reason, we minimize the test time and the TAM width. Both test time and the silicon for TAM are purchased; hence cost in $.

The test flow impacts the test cost. For non-stacked ICs, the test flow is well-defined and consists usually of two test instances; *wafer sort* (testing of the unpackaged chip (bare die)) followed by *package test (final test)* (testing the packaged chip). At the two test instances, the TAM design is the same and, typically, the test plan is the same. It is therefore sufficient to find one optimized TAM design and one single test plan; an order in which the cores of the IC are tested. The test plan is first applied at wafer sort and then at package test using the same TAM architecture. For SICs it is very different. Testing can be applied at the following instances: *wafer sort* (testing individual chips prior to integration into the stack), *intermediate test* (testing a partially constructed stack), *post-bond test* (testing the complete chip stack), and *package test* (testing all chips in the packaged IC). We make two observations. *First*, the more test instances that are used, the higher is the chance to detect manufacturing defects. However, more test instances lead to higher test cost, especially in terms of test time. Reducing the number of test instances, decreases the test time but may lead to a higher manufacturing cost. If, for example, only package test is performed, all chips in the stack are wasted if a single chip is defective. *Second*, the testable units differs between the test instances. As will be detailed in Section II, optimizing the TAM design and the test plan considering the cores at each chip separately, leads to a sub-optimal solution when all cores are jointly tested during package test. In the worst case, it leads to a TAM design that is infeasible for package test.

In our previous work [4], we studied the test flow problem and showed that it is most suitable to use a test flow which

consists of wafer sort of each individual chip and package test of the complete stack of chips. In this paper, we assume such test flow, and address the problem of finding the most suitable test plan and TAM design for testing the cores of each chip during wafer sort *and* for testing all cores of the complete chip stack during package test such that the overall test cost, given as a function the test time and the TAM width, is minimal. As will be shown in the paper, efficient optimization of the test plan and the TAM must jointly consider testing of each individual chip at wafer sort and the testing of the complete stack at package test. We make use of an Integer Linear Programming (ILP) model to minimize the overall test cost. We applied our scheme on several designs constructed from ITC'02 benchmarks and compared the results against two schemes for non-stacked ICs. The experiments show that proposed scheme results in significant lower test cost.

The rest of the paper is organized as follows. In Section II, related work is reviewed and the work in current paper is motivated. The proposed ILP formulation is detailed in Section III and the experimental results are presented in Section IV. The paper is concluded in Section V.

II. RELATED WORK AND MOTIVATION

In this section we first detail previous related work on test planning and TAM design for non-stacked ICs. To motivate the need of current paper, we then demonstrate shortcomings when using schemes that are developed for non-stacked ICs when developing TAM design and test planning for SICs. Finally, we review related works on SICs to demonstrate the novelty of current paper.

For non-stacked ICs, several works addressed test planning to minimize the test cost for testing core-based systems [5, 6]. Zorian proposed for systems where each core is a testable unit that is tested with built-in self-test (BIST), a scheme to find a test plan where the test cost in test time and DfT hardware is minimized while power constraints are met [5]. The DfT hardware is given by the number of BIST control lines. As all cores employ BIST, the cost of BIST circuitry is not included in the cost function. Chou *et al.* proposed for the same problem a systematic approach where test time is minimized while resource constraints and power constraints are not violated [6].

IEEE 1500 [7] was developed to enable core isolation so that each core can be tested as an independent unit. Several works addressed the co-optimization of test planning and TAM design for core-based systems with IEEE 1500 wrapped cores where the test cost in terms of test time is minimized at given TAM width constraints [8, 9]. In these works, the problem at core-level is to form so called wrapper-chains such that test time and the need of useless test data bits are minimized for a given core with scan elements, that is scan-chains, inputs, outputs, and bi-directionals. The problem is illustrated in Figure 1. The core has 4 scan-chains, each 100 flip-flops long. The scan-chains can form 1, 2, 3, or more wrapper-chains. The test time of the core depends on the number of test patterns, which is fixed, and the number of wrapper-chains, which are to be de-
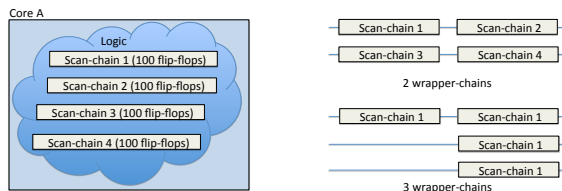

Fig. 1. A wrapped core with logic and scan-chains (left). Scan-chains configured into wrapper-chains (right).
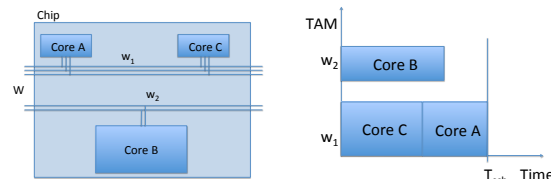

Fig. 2. A test architecture where the TAM width (W) is partitioned into 2 TAMs (w_1 and w_2) (left). A optimized test plan with test time T_{sch}(right).

fined from the scan elements. A low number of wrapper-chains leads to long scan-in and scan-out times, which increases the test time. A higher number of wrapper-chains reduces scan-in and scan-out times but requires higher TAM width to connect the wrapper-chains. The need of additional but useless test data bits depends on how well balanced the wrapper-chains are. Figure 1 shows two wrapper-chain configurations with 2 and 3 wrapper-chains, respectively. The test times are the same as the longest wrapper-chain in each configuration has a length of 200 flip-flops. However, in the case with 3 wrapper-chains, 200 bits of extra useless bits must be added for each pattern to ensure that all scan-chains can capture test data at the same time. Iyengar *et al.* showed that the problem of forming wrapper-chains at core-level is NP-hard and made use of a best fit decreasing (BFD) algorithm to form the scan elements into a given number of wrapper-chains such that test time is minimized [9].

The problem at system-level is given a TAM width (W) to find the most suitable number of TAM groups, their widths, and assign the cores to the TAM groups such that test time is minimized. Figure 2 shows an example of a TAM design (left) and a test plan with test time T_{sch} (right). As the test time at wafer sort (T_{ws}) and the test time at package test (T_{pt}) are equal to T_{sch}, the total test time (T) is $2 \times T_{sch}$. During the optimization, the following two problems must be addressed, which will be illustrated with the help of Figure 2. First, consider Core A (details in Figure 1), which is assigned to w_1 with a width 3. This is sub-optimal when considering Core A alone as 2 wrapper-chains results in equal test time but requires less extra useless test data bits (discussed above). However, taking the overall perspective, the alternative is suitable. Second, the usage of TAMs are not perfectly balanced as w_2 is not fully utilised (not used until T_{sch}). As with unbalanced wrapper-chains, unbalanced TAMs adds extra useless test data.

While the above approaches are suitable for non-stacked ICs, they are not suitable for SICs. Assume a SIC with two
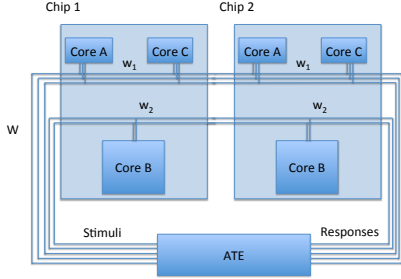
Fig. 3. Package test of a SIC with two identical chips.

identical chips where the TAM and the test plan are optimized for the testing of the individual chips (see Figure 2). At package test, the setup for these two chips connected to an ATE is shown in Figure 3. Note that neither the test plan nor the TAM are optimized for this setup. In this case, due to identical chips, the TAM of the two chips becomes the same. Hence, connecting the chips becomes straight forward. However, in general, the chips in a SIC are not identical. The TAM can differ if each chip is optimized individually. If the widths of the TAMs in Figure 3 differs, it becomes cumbersome or even impossible to transport test data. Assume a stack of chips where the lowest chip is connected to the ATE. If this chip has the lowest TAM width of all chips, there is no bandwidth to send test data to chips higher in the stack designed with higher TAM width. Alternatively, if all chips have the same TAM width but the number and widths of TAMs differs between chips, package test *might* be possible if the chips are tested in a sequence one after the other.

Test planning to reduce test cost given by test time and DfT hardware has for SICs been addressed in [10, 11]. The schemes do however not assume any particular DfT architecture and make it difficult to reuse DfT hardware added for wafer sort test at package testing. We proposed a scheme to minimize test cost given by test time and DfT hardware assuming a JTAG 1149.1 architecture for test data transportation [12]. The main drawback with the JTAG 1149.1 architecture is the low bandwidth for test data transportation. Marinissen *et al.* proposed an architecture with IEEE 1500 compatible wrappers to enable core-based testing of SICs [13]. While, the architecture enables core-based test of SICs; there is no TAM design and test planning scheme proposed for SICs, which is the topic of current paper.

III. ILP FORMULATION

In this section, we detail the ILP formulation. The used notations are collected in Table I. Figure 4, which will be used to illustrate the notations, shows a SIC with $I = 2$ chips (chip 1 and chip 2). Chip 1 contains $C_1 = 3$ cores denoted c_{11}, c_{12}, and c_{13}. Chip 2 contains $C_2 = 4$ cores denoted c_{21}, c_{22}, c_{23}, and c_{24}. Figure 4 shows that the TAM width $W = 5$ is distributed into $K = 2$ TAM groups, w_1 and w_2. The width of

Notation	Definition
i, I	Chip i in a SIC with I chips where $i \in 1..I$
c_{ij}	Core c_{ij} is core j at chip i where $j \in 1..C_i$ and C_i is the number of cores at chip i
wc_{ij}	Number of wrapper-chains at core c_{ij}
W	Total TAM width
w_k, K	TAM group w_k where $k \in 1..K$ and K is the total number of TAM groups
$T_{c_{ij}}(wc_{ij})$	Test time of core c_{ij} when the scan elements are formed into wc_{ij} wrapper-chains
T_{w_k}	Test time of all cores assigned to TAM w_k
T_{ws_i}	Test time for wafer sort of chip i
T_{pt}	Test time for package test of the SIC (all chips jointly)
T	Total test time which is the sum of all times at wafer sort and package test, given as: $\sum_{i \in I} T_{ws_i} + T_{pt}$
test cost	Total test cost given as: $\alpha \times T + \beta \times W$
α, β	α and β are designer specified constants to capture the importance of test time and TAM, respectively
y_{ijk}	1 if core c_{ij} is assigned to TAM w_k; otherwise 0

w_1, given by $|w_1|$, is 3. The scan elements at core c_{11} are formed into wc_{11} wrapper-chains. As the width of w_1 is 3, the number of wrapper-chains at c_{11} can be no more than 3.

Given as input to the ILP is a core-based SIC with I chips where all cores are wrapped with IEEE 1500 wrappers. As all cores are wrapped, the cost of wrappers is fixed and the additional DfT hardware is only depending on the TAM width W. The output of the ILP is:

- a TAM design where defined is the TAM width W, the K number of TAM groups, and the width of each TAM group w_k is $|w_k|$, and

- a test plan where the scan elements at each core are formed into wrapper-chains and the cores are assigned to TAM groups.

The objective is to find a TAM architecture and a test plan with minimal cost in TAM width and test time. It should be noted that both test time and silicon for DfT are to be purchased, which means the cost function defines the cost in $. The general form of the ILP model is as follows [14]:
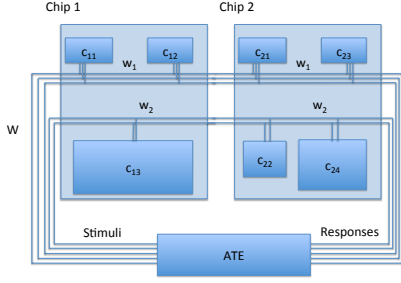
Fig. 4. Illustration of notations.

Minimize: $A \times x$
subject to: $B \times x \leq C$

where A is the objective function, B defines the constraints, C is the constants, and x is a vector of integer variables.

The objective function to be minimized is the *test cost* given as:

$$\alpha \times T + \beta \times W \tag{1}$$

where W is the TAM width, T is the total test time of wafer sort of each chip i *plus* the test time of the complete SIC, and α and β are user-defined constants set to define the importance of test time and DfT hardware.

Below we detail the computation of the total test time T. $T_{c_{ij}}(w_k)$ denotes the test time of a core c_{ij} when the scan elements are formed in $|w_k|$ wrapper-chains and assigned to TAM group w_k is given by the Best Fit Decreasing (BFD) algorithm for wrapper-chaining [9]. For example, the test time of Core A in Figure 1 when the four scan chains of length 100 flip-flops are formed as three wrapper-chains is given as: $(200 + 1) \times p + 200$ where p is the number of patterns (+1 is for the capture cycle).

The test time of all cores at chip i assigned to TAM group w_k is given by:

$$^{i}T_{w_k} = \sum_{j \in C_i} T_{c_{ij}}(w_k) \times y_{ijk} \tag{2}$$

where y_{ijk} is 1 only if core c_{ij} is assigned to TAM group w_k. The test time of cores assigned to TAM group w_1 in Figure 4 is given as the sum of test time of the cores c_{11} plus c_{12}.

The wafer sort test time T_{ws_i} of chip i is given by:

$$T_{ws_i} = \max_{k \in K}\{^{i}T_{w_k}\} \tag{3}$$

The wafer sort test time T_{ws_1} of the chip in Figure 2 is given as the sum of the test times of Core A+Core C.

The test time of all cores in all I chips in the SIC assigned to TAM group w_k is given by:

$$^{I}T_{w_k} = \sum_{i \in I} \sum_{j \in C_i} T_{c_{ij}}(w_k) \times y_{ijk} \tag{4}$$

where y_{ijk} is 1 if core c_{ij} is assigned to TAM group w_k. The test time of the cores assigned to TAM group w_1 in Figure 4 is

Label	Design	Cores
D	d695	11
G	g1023	15
P	p34392	20
T	t512505	32

given as the sum of the test time of the cores c_{11} plus c_{12} plus c_{22} plus c_{23}.

The test time for package test T_{pt} of the I chips in the SIC is given by:

$$T_{pt} = \max_{k \in K}\{^{I}T_{w_k}\} \tag{5}$$

where $^{I}T_{w_k}$ denotes the test time of all cores assigned to TAM w_k.

While Eq. 3 and Eq. 5 have similarities, note that the former only considers the cores at one given chip i while the latter considers all I chips.

Finally, the total test time T is the sum of the wafer sort test time T_{ws_i} of chip i and the package test time T_{pt} of the complete SIC:

$$T = \sum_{i \in I} T_{ws_i} + T_{pt} \tag{6}$$

The constraints are as follows:

- The sum of the TAM widths w_k at each chip is:

$$\sum_{k \in K} |w_k| \leq W \tag{7}$$

- Each core c_{ij} is assigned to exactly one TAM group w_k where the number of wrapper-chains (wc_{ij}) at core c_{ij} satisfies $wc_{ij} \leq w_k$ (all I chips). The number of wrapper-chains at a core cannot be higher than the width of the TAM group to which the core is assigned. The number of wrapper-chains can, however, be less. For example, while a core with only one scan-chain can only form one wrapper-chain, this wrapper-chain can be assigned to a TAM group that has a width higher than one. It is not optimal as it enforces extra test bits.

- Each wrapper-chain is assigned to exactly one TAM wire.

IV. EXPERIMENTAL RESULTS

The objective of the experiments is to demonstrate that the proposed ILP scheme results in a lower test cost compared to when making use of schemes developed for non-stacked ICs. The proposed ILP scheme for SICs is detailed above and the following two schemes for non-stacked ICs were used.

- Scheme 1, the TAM for each chip is optimized independently of all other chips in the SIC. It means that each chip gets the TAM that is most suitable for its wafer sort.

TABLE III
SCHEME 1 WHERE TEST ARCHITECTURE FOR EACH CHIP IS OPTIMISED INDIVIDUALLY

Designs	TAM architecture		Test time						Test cost
	TAM width	TAM cost	Wafer sort				Package test	Total time	
			Chip 1	Chip 2	Chip 3	Chip 4			
DP	30	15201815	23194	545763			2133589	1137914	16339729
DT	32	51500032	21745	5166376			11858562	10376242	61876274
GP	30	2210774	24381	545763			814491	1140287	3351061
GT	32	25240421	22857	5166376			8302773	10378466	35618887
DGP	30	1917965	23194	24381	711865		773919	1186676	3104640
DGT	32	16221562	21745	22857	6612961		6670052	10421956	26643517
DPT	32	10829574	21745	511653	5166376		5699774	11399547	22292026
GPT	32	77025301	22857	511653	13777003		15202362	11401772	88489977
DGPT	32	14201482	21745	22857	584746	5904430	6540149	11445261	25709647

TABLE IV
SCHEME 2 WHERE TEST ARCHITECTURE IS OPTIMIZED FOR THE LOWEST CHIP IN THE STACK AND USED FOR ALL CHIPS

Designs	TAM architecture		Test time						Test cost
	TAM width	TAM cost	Wafer sort				Package test	Total time	
			Chip1	Chip2	Chip3	Chip4			
DP	8	4053817	86979	2046611			2133589	4267179	8320996
DT	8	12875008	86979	20665505			20752483	41504966	54379974
GP	20	1473849	36571	818644			855216	1710431	3184280
GT	20	15775263	36571	8266202			8302773	16605546	32380809
DGP	8	511457	86979	91428	2046611		2225017	4450035	4961492
DGT	8	4055390	86979	91428	20665505		20843911	41687822	45743212
DPT	8	2707394	86979	2046611	20665505		22799094	45598188	48305582
GPT	20	48140813	36571	818644	8266202		9121417	18242835	66383648
DGPT	8	3550370	86979	91428	2046611	20665505	22890522	45781044	49331414

Note that after the optimization additional TAM wires can be added to a chip. For example, if the top chip requires a very wide TAM while all other chips only need a narrow TAM, the wide TAM is added to all chips to make testing of the top chip possible at package test.

- Scheme 2, the TAM for the lowest chip is optimized and the same test architecture is used for all chips in the SIC. In this case, all chips use the TAM optimized for wafer sort test of the lowest chip.

For the experiments, core-based SICs were constructed using four ITC'02 benchmarks: d695 (D), g1023 (G), p34392 (P), and t512505 (T), see Table II. To give an indication of the complexity of the designs, Table II also details the number of cores. Each of the ITC'02 benchmarks form a chip and by combining the four benchmarks in various ways, SICs with 2, 3 and 4 chips were constructed. For example, the DP design in Table III is a SIC with 2 chips consisting of d695 and p34392 where d695 is the lowest chip.

For the constants α and β in the test cost (Eq. 1), we performed some experiments and found that suitable are the following settings: $\alpha = 1$ and $\beta = T_{max}/(0.5 \times (TAM_{max} - TAM_{min})^2)$ where T_{max} is the test time when all chips are tested assuming one single wrapper-chain, TAM_{max} is set to T_{max}/s where s is the length of the longest scan-chain, and $TAM_{min} = 1$. By setting α and β in this way, we have a general scheme for all design. Obviously, a designer can set α and β in the most appropriate way for a given design. For the

search space with respect to TAM width W, we have a general limit that has been used for all experiments. The highest allowed TAM width is limited by computing the sum of the test times of all cores assuming a single wrapper-chain. To obtain the highest TAM limit, this value is divided with the test time of the core with highest test time.

The results from the non-stacked schemes are in Tables III and IV. The results from the proposed SIC scheme are in Table V. The comparison between the three schemes is in Table VI. Tables III, IV and V are constructed in the same way. The designs are listed in column one, the TAM width and the TAM cost are in column two, the test time at wafer sort for each chip where applicable, the test time at package test, the total test time are in column three, and the test cost for each design is in column four.

The comparison between the two non-stacked schemes against the SIC scheme is in Table VI. Table VI is organised as follows. Column one lists the designs. Columns two, three and four are organised in the same way with the test time, the TAM cost and the test cost for the two non-stacked schemes and the proposed SIC scheme. Column five reports the comparison between the non-stacked schemes and the SIC scheme. The results show that the SIC scheme produces the lowest test cost in all cases. For the benchmark DP, the SIC scheme is 125% better than Scheme 1 and 14% better than Scheme 2. At an average over all designs, the SIC scheme is 40% better than Scheme 1 and 63% better than Scheme 2.

TABLE V

PROPOSED SIC SCHEME WHERE TEST ARCHITECTURE AND TEST PLANNING ARE CO-OPTIMIZED FOR ALL CHIPS

Designs	TAM architecture		Test time							Test cost
	TAM width	TAM cost	Wafer sort				Package test	Total time		
			Chip1	Chip2	Chip3	Chip4				
DP	8	2987025	86979	2046611			2133589	4267179		7254204
DT	12	16601987	49702	11808860			11858562	23717124		40319110
GP	22	1140287	34830	779661			814491	1628982		2769269
GT	18	11623882	36571	8266202			8302773	16605546		28229428
DGP	22	1083487	30253	31801	711865		773919	1547838		2631325
DGT	24	9338072	27833	29257	6612961		6670052	13340103		22678175
DPT	35	7979683	21745	511653	5166376		5699774	11399547		19379230
GPT	11	21283307	60952	1364407	13777003		15202362	30404725		51688032
DGPT	27	9156218	24851	26122	584746	5904430	6540149	13080298		22236517

TABLE VI

TEST COST COMPARISON BETWEEN SCHEMES FOR NON-STACKED ICs AND THE PROPOSED SIC SCHEME

Designs	Scheme 1 (Table III)			Scheme 2 (Table IV)			SIC scheme (Table V)			Test cost (%) SIC versus	
	Time	TAM	Test cost	Time	TAM	Test cost	Time	TAM	Test cost	Scheme 1	Scheme 2
DP	1137914	15201815	16339729	4267179	4053817	8320996	4267179	2987025	7254204	125.24	14.71
DT	10376242	51500032	61876274	41504966	12875008	54379974	23717124	16601987	40319110	53.47	34.87
GP	1140287	2210774	3351061	1710431	1473849	3184280	1628982	1140287	2769269	21.01	14.99
GT	10378466	25240421	35618887	16605546	15775263	32380809	16605546	11623882	28229428	26.18	14.71
DGP	1186676	1917965	3104640	4450035	511457	4961492	1547838	1083487	2631325	17.99	88.55
DGT	10421956	16221562	26643517	41687822	4055390	45743212	13340103	9338072	22678175	17.49	101.71
DPT	11462452	10829574	22292026	45598188	2707394	48305582	11399547	7979683	19379230	15.03	149.26
GPT	11464676	77025301	88489977	18242835	48140813	66383648	30404725	21283307	51688032	71.20	28.43
DGPT	11508166	14201482	25709647	45781044	3550370	49331414	13080298	9156218	22236517	15.62	121.85
									Average:	40.36	63.23

V. CONCLUSION

In this paper we propose a scheme for test planning and test architecture design for core-based SICs based on ILP where the test cost, given as the test time and TAM cost, is minimized. We assume a test flow where each chip is individually tested at wafer sort and all chips (the complete SIC) are jointly tested at package test. In the experiments we compare the proposed scheme against two schemes for non-stacked ICs. The results show that proposed scheme results in a test cost at an average of 40% and 63%, lower than the two schemes for non-stacked ICs, respectively. As future works, we will not only address TAM constraints but also general test conflicts and test power constraints.

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